



BA

03560.002760.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Shuichi YABU ) : Examiner: A. Mathews  
Application No.: 09/811,447 ) : Group Art Unit: 2851  
Filed: March 20, 2001 ) : Allowed: July 1, 2003  
For: EXPOSURE APPARATUS, GAS ) : Confirmation No.: 9561  
REPLACING METHOD, AND METHOD : September 5, 2003  
OF MANUFACTURING A )  
SEMICONDUCTOR DEVICE :

**Mail Stop Issue Fee**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed June 24, 2003, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.

The information enclosed with this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing date of this Statement. Specifically, the attached Korean Office Action dated August 1, 2003, was cited in a counterpart Korean patent application. A translation of this Office Action will be provided if the Examiner so requires.

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Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

SEP 05 2003

REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

September 5, 2003

ATTY DOCKET NO. 03560.002760.

APPLICATION NO. 09/811,447

APPLICANT Shuichi YABU

FILING DATE March 20, 2001

GROUP 2851

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	US-5,399,448	03/21/1995	Nagata et al.	430	5		

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

Korean Office Action dated August 1, 2003, issued in a corresponding Korean patent application.

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.